



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 12, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG711502777

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

7.58 - 7.62 X 4.67 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.67 CARAT

D

VS 1

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

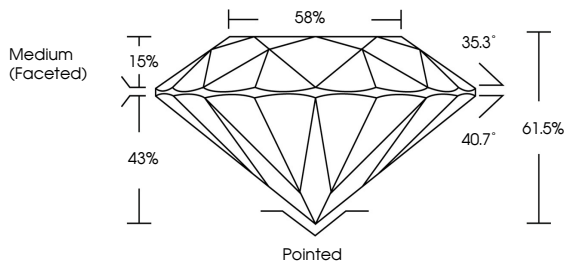
EXCELLENT

NONE

 LG711502777

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Medium (Faceted)

58%

35.3°

40.7°

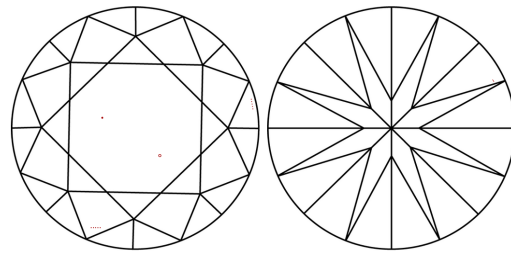
61.5%

43%

15%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

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ROUND BRILLIANT

7.58 - 7.62 X 4.67 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium (Faceted)

1.67 CARAT

D

VS 1

IDEAL

61.5%

58%

Pointed

EXCELLENT

EXCELLENT

NONE

 LG711502777

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

None

EXCELLENT

EXCELLENT

NONE

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Type IIa